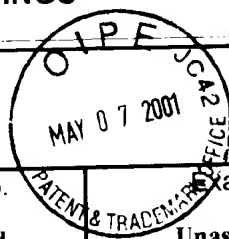


TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
14463

In Re Application Of:

Haruo Sunakawa



Serial No.	Filing Date	Batch No.	Examiner	Art Unit
09/821,411	March 29, 2001	Unassigned	Unassigned	Unassigned

Invention: **METHOD OF MANUFACTURING A NITROGEN-BASED SEMICONDUCTOR SUBSTRATE AND A SEMICONDUCTOR ELEMENT BY USING THE SAME**

Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

5 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

RECEIVED
MAY 15 2001
10:20 AM

Signature

Dated: May 2, 2001

Paul J. Esatto, Jr. Registration 30,749

SCULLY, SCOTT, MURPHY & PRESSER
400 Garden City Plaza
Garden City, New York 11530
(516) 742-4343

I certify that this document and attached formal drawings are being deposited on May 2 2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Mishelle Mustafa

Typed or Printed Name of Person Mailing Correspondence